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AP3 Rec'd PCT/PTO 09 JUN 2006

Attorney Docket No. 081468-0352017  
Client Reference: P-1755.020-US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Frits Jurgen VAN HOUT, Josephus Antonius Maria VAN BOMMEL, Peter DIRKSEN, Mark KROON, Casparus Anthonius Henricus JUFFERMANS, and Renatus Maria Adrianus Mathias VAN DEN EIJNDEN

Application No.:	NEW	Confirmation No:	UNKNOWN
Filed:	June 9, 2006	Group No.:	UNKNOWN
		Examiner	UNKNOWN
For:	SENSOR FOR LITHOGRAPHIC APPARATUS AND METHOD OF OBTAINING MEASUREMENTS OF LITHOGRAPHIC APPARATUS		

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

APPLICATION DATA SHEET  
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: Frits Jurgen VAN HOUT  
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Fifth applicant: Casparus Anthonius Henricus JUFFERMANS  
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Sixth applicant: Renatus Maria Adrianus Mathias VAN DEN EIJNDEN  
Citizenship: The Netherlands  
Residence: August Sniederslaan 20, NL-5615 GE Eindhoven, The Netherlands

**2. Correspondence information**

Correspondence for this application should be addressed as follows:

Customer No.: 00909

**3. Application information**

Title of Invention: SENSOR FOR LITHOGRAPHIC APPARATUS AND METHOD OF OBTAINING MEASUREMENTS OF LITHOGRAPHIC APPARATUS

Docket number assigned to this application: 081468-0352017

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 2

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

**4. Representative information**

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

**5. Domestic Priority information**

Domestic priority for this application is claimed as follows:

35 U.S.C. § 119(e):

Application No.: 60/608,938

Filed: December 9, 2003

Status: Expired

Relationship: Parent Provisional

35 U.S.C. § 365(c):

Application No.: PCT/NL2004/000855

Filed: December 9, 2004

Status: Published as WO 2005/057290 A2

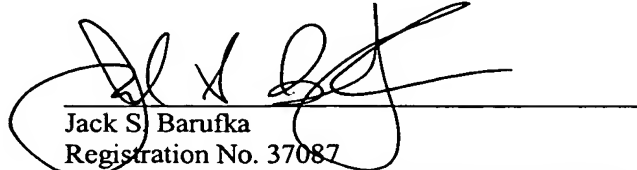
**6. Assignee information**

The assignee of this application is:

ASML Netherlands B.V.  
De Run 6501  
Veldhoven, NL-5504 DR  
The Netherlands

Extent of interest of assignee in application: Entire right, title and interest.

Date: June 9, 2006

A handwritten signature in black ink, appearing to read 'J. S. Barufka', is written over a horizontal line.

Jack S. Barufka

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